



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 6, 2026	
IGI Report Number	LG843684059
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	MARQUISE BRILLIANT
Measurements	13.60 X 6.56 X 4.13 MM

GRADING RESULTS

Carat Weight	2.07 CARATS
Color Grade	F
Clarity Grade	VVS 2

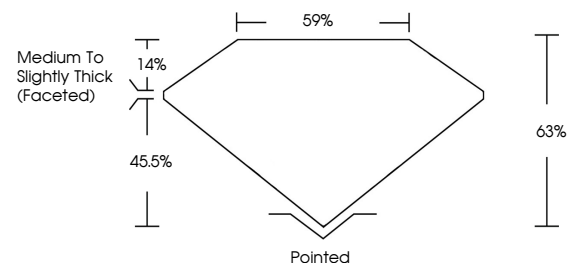
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG843684059

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

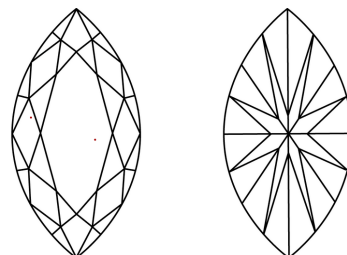
LG843684059
Report verification at igi.org

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

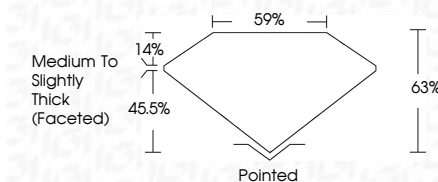
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www.igi.org

October 6, 2026	2.07 CARATS
GI Report No. LG945694059	F
MARQUESE BRILLIANT	VVS 2
13.40 X 6.55 X 4.13 MM	65%
	69%
	Medium to Slightly Thick (Faceted)
	Pointed
	EXCELLENT
	EXCELLENT
	NONE
	ISS: LG945694059

Comments: This is a very large diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa